

JS501-400 Spin Coater

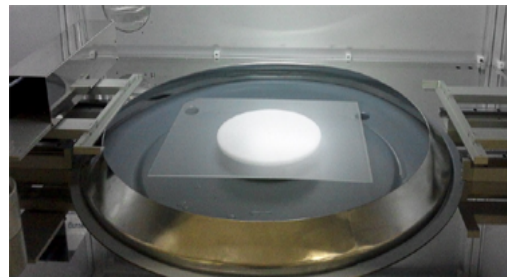
370x470 mm Spin Coater

The JS501-400 of large substrate spincoaters is designed for versatility, ease of use and safety in a variety of manual and automated research and development processes. The spincoaters are ideal for processes such as the coating and developing of silicon wafers, glasses, large photomasks, reticles.

- Precise temperature control
- Combined with a spraying nozzle for large area coating
- Easy to be modified for spray coater
- Repeatable performance
- Flexibility for programming
- Auto liquid dispensing system
- 4 different liquids controlled

Specification

Programmable 20 steps, 20 recipes stored
PLC and Touch panel operation
Accuracy ± 1 RPM
Max RPM: 3,000
Acceleration: 1,000RPM/sec.
SUS304 body and bowl
for easy cleaning and chemical resistance
Drain port
HEPA filter unit
Max 370x470mm, 1T glass
Standard dry vacuum pump: 100 liter/ min, 0.5 ATM
Standard sample chuck
Dimension 1500W x 1200D x 1650H mm
220VAC, 60Hz, 25 amp
Weight: 225 Kg



JAESUNG JS501 SPIN COATING SYSTEM

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SOLUTIONS PROVIDER

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